

7th International Conference on
New Developments In Photodetection

Tours, France, June 30th to July 4th **2014**



Micro-Channel Plates And Vacuum Detectors

Thierry Gys
(CERN/PH-DT)

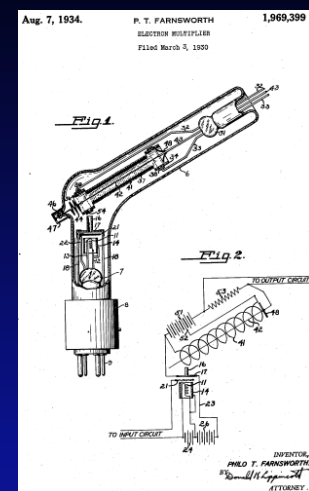


- Much more has been and is taking place than what can be covered in 45 minutes!
- This (partially historical) review is actually a mix between an overview, a tutorial and a highlight from the viewpoint of a modest MCP user
- The selection criteria were a combination of
 - the speaker's past and current activities and interests
 - those MCP-related developments coming from relatively old, new and near-future R&D and experiment projects
 - topics which are generally covered in other oral or poster presentations during this Conference
 - topics the illustrations of which were easily accessible, directly via authors, publications and web sites

- History – the channel electron multiplier
- From large-size single channels to micro-channel plates
- Gen II image intensifiers
- Applications in scintillating fibre tracker detectors
- Re-discovering the MCP-PMT for fast timing
- Applications in time-of-flight and particle identification and related recent developments
- Conclusions and perspectives

- Combination of secondary emissive dynode and resistive chain

US Patent
1,969,399



- First proposed in 1930 by Farnsworth

- Modulated electron stream
- Hollow resistor
- Central electrode coated with Th (45eV/e-) or Ba (33eV/e-)
 - Evaporate on resistor
 - Increase $e^- \cdot v_t$

Instr. and Exp. Tech. 4
(1960) 611

- Linear up to space charge effects

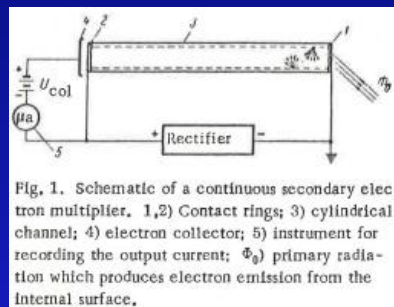
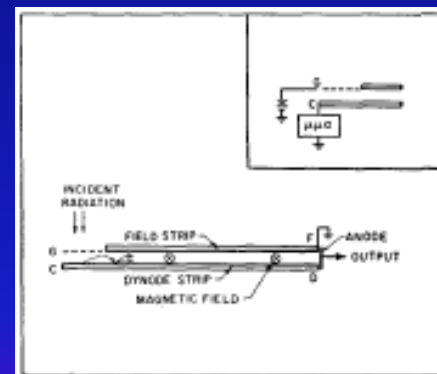


Fig. 1. Schematic of a continuous secondary electron multiplier. 1,2) Contact rings; 3) cylindrical channel; 4) electron collector; 5) instrument for recording the output current; Φ_0) primary radiation which produces electron emission from the internal surface.

- Further developed in 1960's

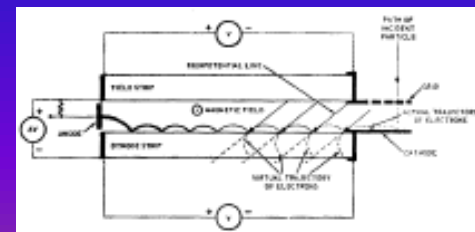
- Oschepkov et al.
 - No central electrode
 - $TiO_2 + MgO$
- Heroux and Hinteregger
 - $SnO + Sb$ -coated glass
- Goodrich and Wiley

Rev. Sci. Instr. 31
(1960) 280

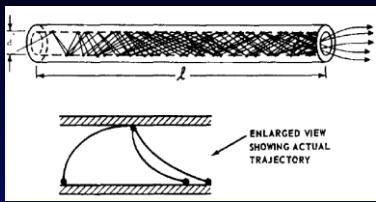


“They may either be made of a conducting coating on an insulating base or they may consist of the surface of a material with the proper volume resistivity for convenient operation”

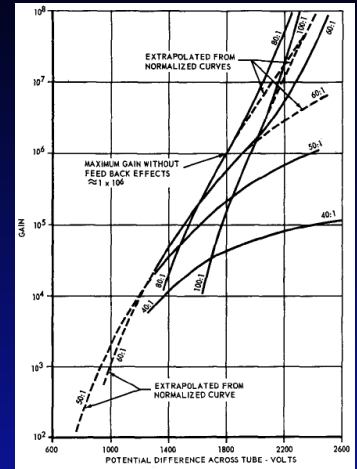
Rev. Sci. Instr. 32
(1961) 846



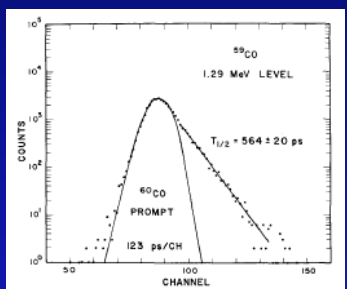
- Hollow tube replace strips, no B field
 - Parallel array possible
 - ϕ range 0.04-0.004"
- Typical secondary emitters
 - AgMgO (Cs) GaP(O) $\epsilon > 10$
 - Initial e- emission energy of a few eV



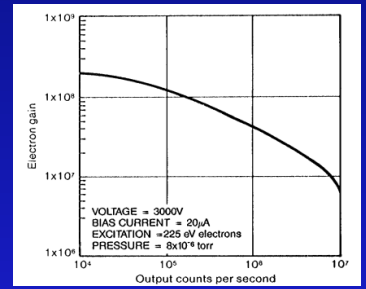
Rev. Sci. Instr. 33 (1962) 761



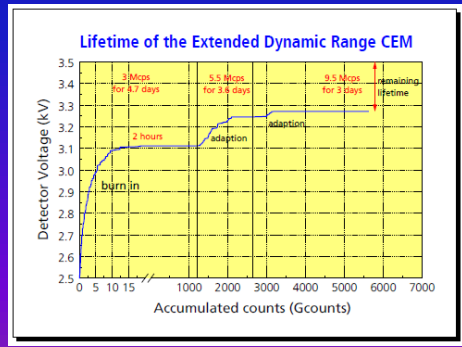
- Achieve high gains up to 10^8
- Ion feed-back limitations => curved channels
- Time resolution ~ 500 ps
 - Measurement of short lifetimes of nuclear energy states



NIMA99 (1972) 445



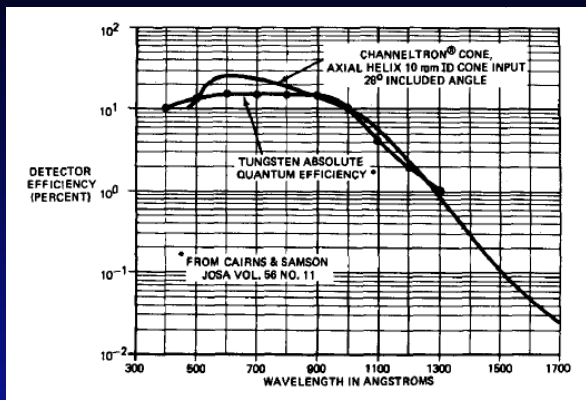
- Count rate up to 10^7
- Lifetime up to 5000GCounts



Channeltron (Burle)

SPECS GmbH

- Numerous applications in space, mass spectrometry, ...
 - E.g “A secondary standard vacuum ultraviolet detector” by M.C. Johnson (Bendix)

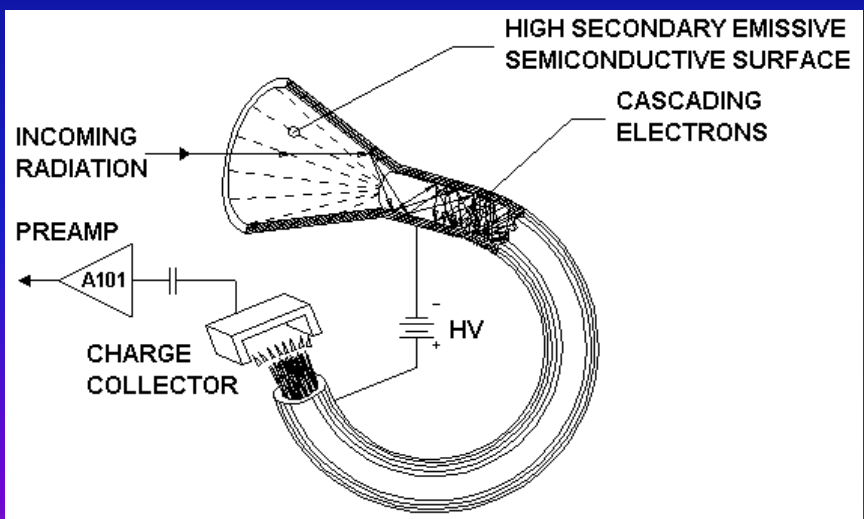


Rev. Sci. Instr. 40,2 (1969) 311



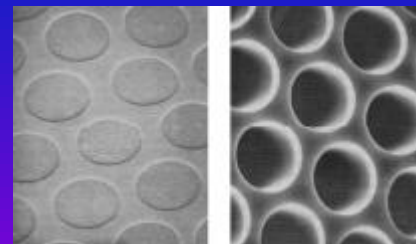
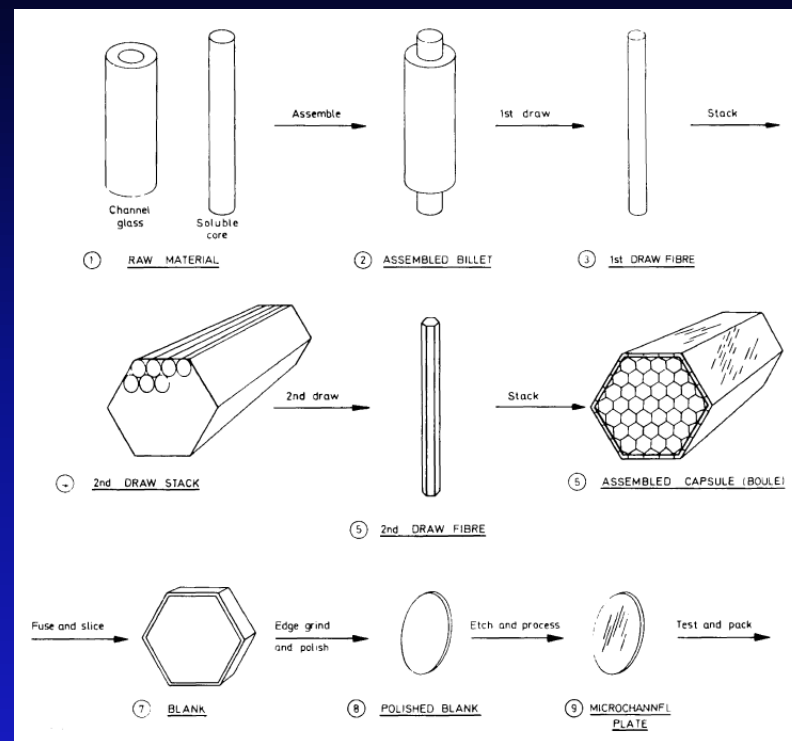
Channeltron (Burle)

Amptekron (Amptek)



- Production of resistive surfaces in Pb-glass by high T reduction in hydrogen
 - See K. Blodgett J. Am. Ceram. Soc. 34,1 (1951) 14
- The same technology that produced optical fibres and fibre optic bundles, with a slight change in manufacturing, allowed the production of micro-channel plates
- Manufacturing steps
 - Hollow tube of non-etchable glass
 - Core of etchable glass
 - Heated and drawn (0.8mm ϕ)
 - Bundled to hexagon rod
 - Drawn again
 - Fused and sliced
 - Polished and etched
 - Heated under H₂ and “electroded” (NiCr)
 - Pre-conditioning through electron scrubbing

VALVO

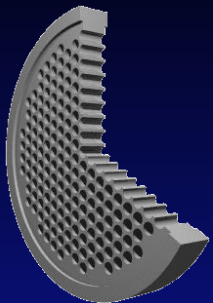


NIM162
(1979) 587

- Glass surface resistivities 10^7 to $10^{13} \Omega/\square$

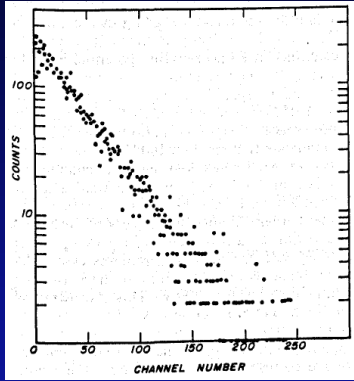
- Geometry

- $d \sim 6-25 \mu\text{m}$
- $L \sim 400-1000 \mu\text{m}$
- $\alpha = L/d \sim 40-100$, defines gain
- $\text{OAR} \sim 55-65\%$



- Straight channel

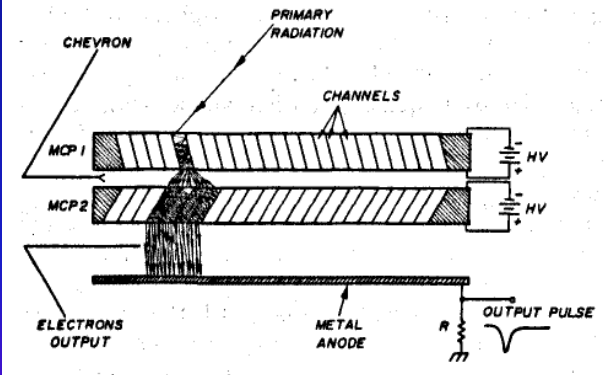
- Typical gain 10^3-10^4
- IFB limited
- Negative exponential PHS



NIM162 (1979) 587

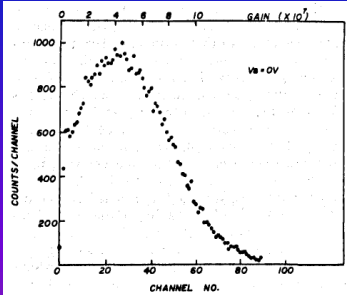
- Curved channel

- Space-charge limited – dynamic equilibrium
- Quasi Gaussian PHS
- Difficult to bend if small-sized



- Chevron

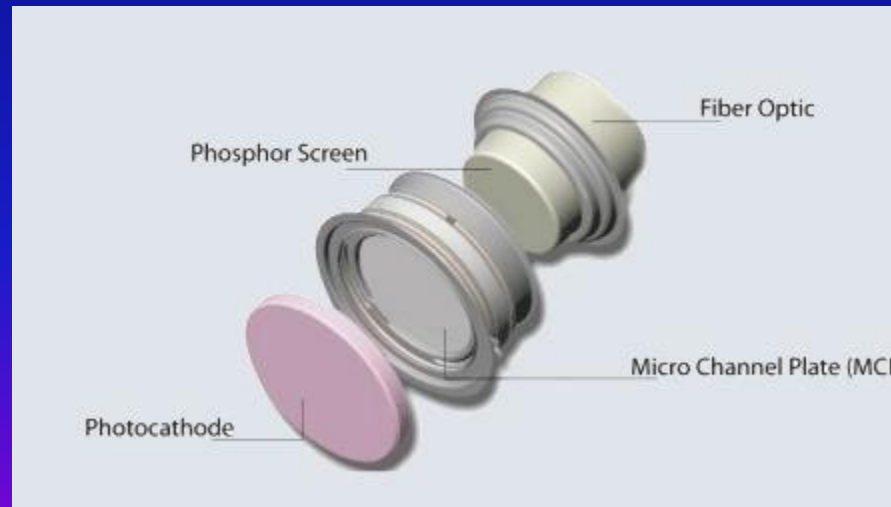
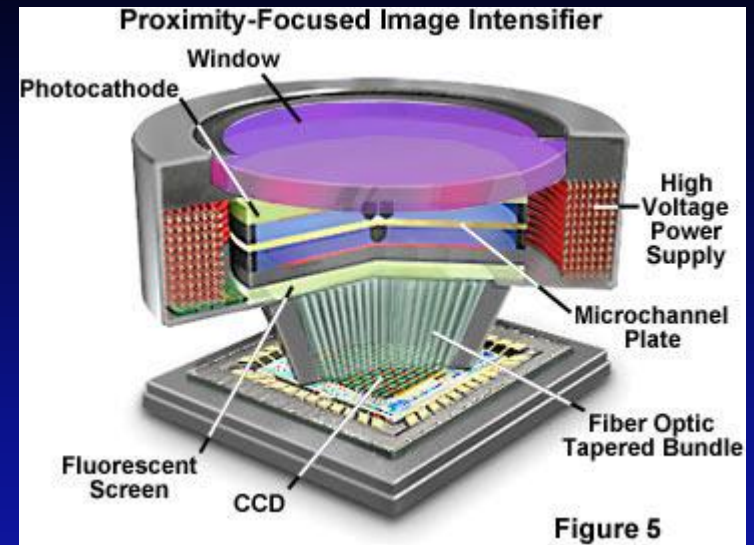
- Typical gain 10^6-10^7
- $\text{Gain} \propto d$ for fixed V/α
- PHS



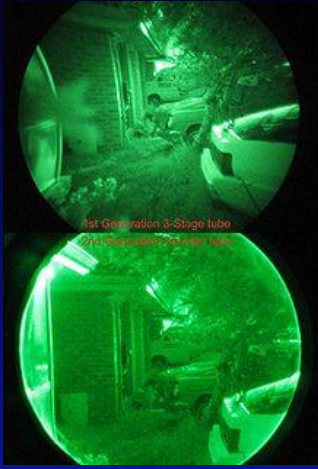
- Driving market
 - Night vision
 - Military applications

- Typical structure
 - Optical input window
 - Photocathode
 - MCP (chevron)
 - Phosphor screen
 - Optical fibre bundle
 - CCD readout

<http://www.microscopyu.com/print/articles/digitalimaging/digitalintro-print.html>



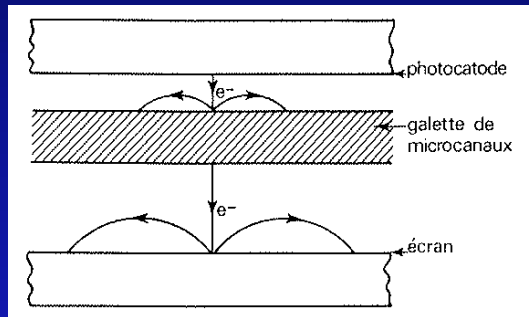
- Image features
 - High gain
 - No pin-cushion distortion (Gen I)



Gen I

Gen II

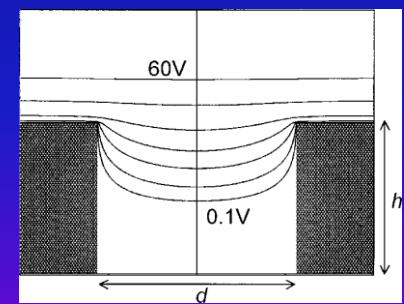
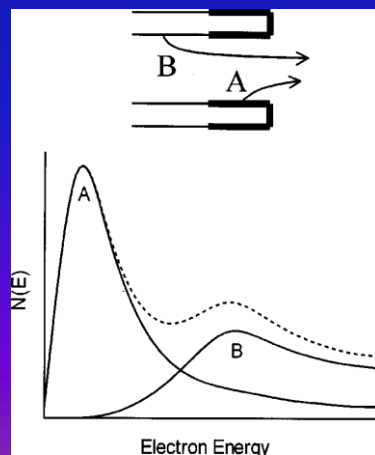
Acta Electronica 20,4
(1977) 369



- Spatial resolution (and time)
 - Photon energy
 - Tube gaps

- Halos (and time tails)
 - Back-scattering
 - Tube gaps
 - PC-MCPin gap can be as small as 120μm

- End-spoiling
 - Increased spatial resolution
 - ... to some extent (lens effect)
 - What about timing effects?



J. Vac. Sci. Tech. B 19
(2001) 843

- UA2 tracker upgrade
 - Search of e^- with $p_T \sim 10-30 \text{ GeV}/c$ as a signature for top quark production

- Cascade of 3 image intensifiers
- 1st stage is Gen I

- Good coverage
- De-magnification required to match Gen II size

- 2nd stage is Gen II

- High gain

- 3rd stage is Gen I

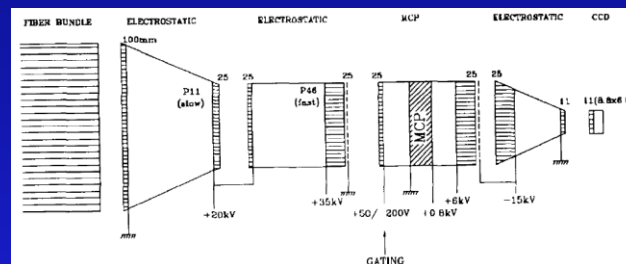
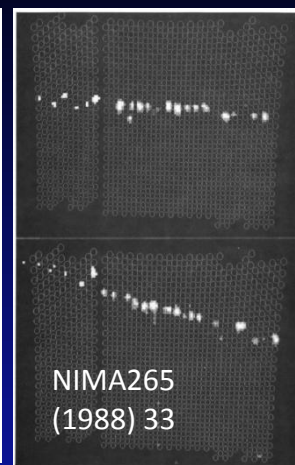
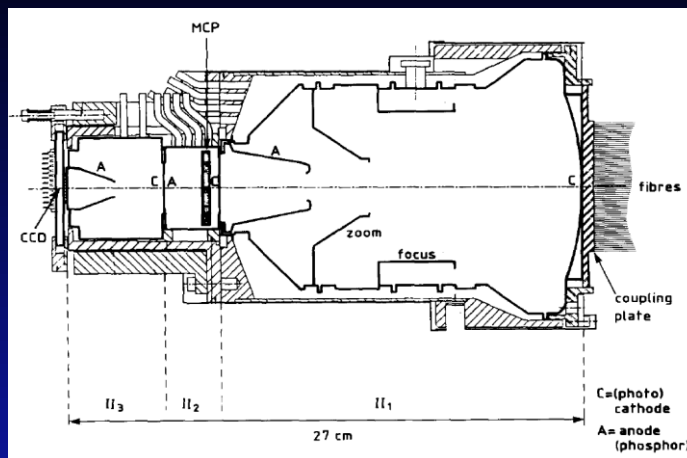
- De-magnification required to match CCD size

- CHORUS

- Search for $\nu_\mu - \nu_\tau$ oscillations
- Fibre tracker restricts search for vertex location $\nu_\tau N \rightarrow \tau, X$ in bulk emulsion

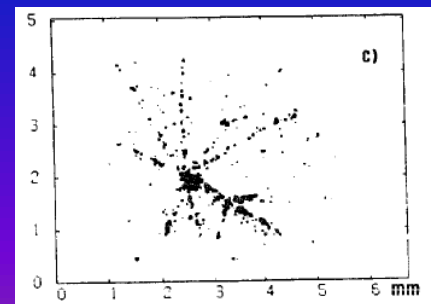
- WA84

- Beauty search with scifi microvertex detector



NIMA344 (1994) 143

NIMA289 (1990) 342

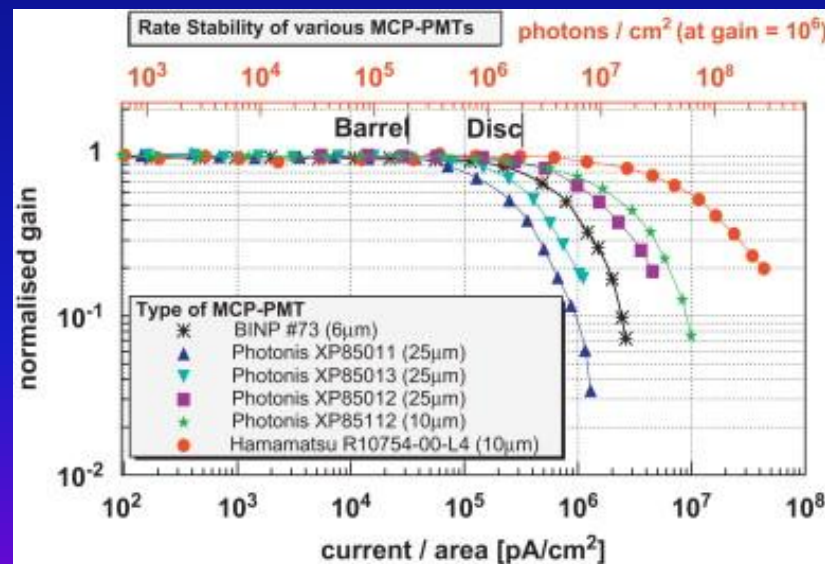


- Some interesting features
 - Square shapes
 - Better overall coverage
 - Single-photon sensitive
 - High gain
 - Collection efficiency $\sim 60\%$
 - Compact, high E field
 - Small TTS
 - Works in large (axial) magnetic fields
 - Good rate capability (the smaller d the better)
 - Position-sensitive
 - Appropriate anode segmentation

Photonis

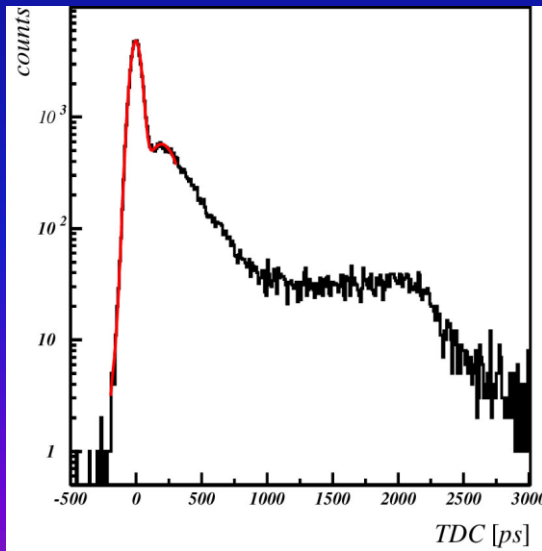
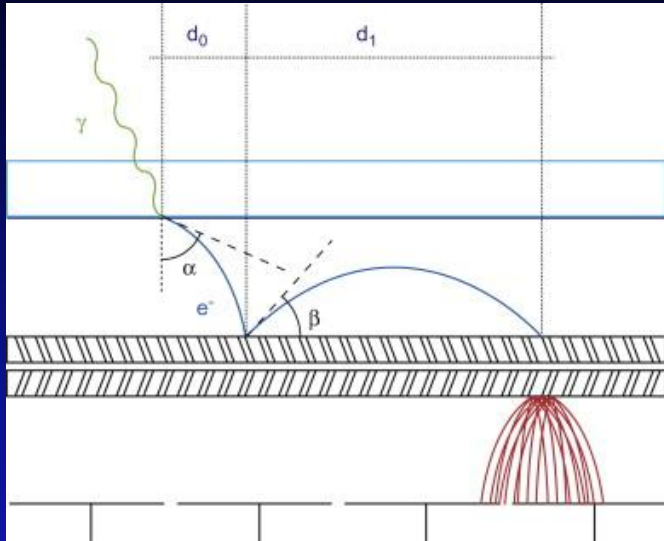


Hamamatsu



NIMA 695
(2012) 68

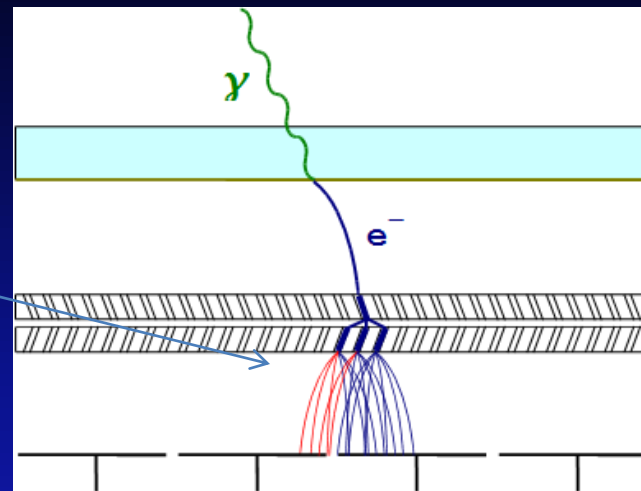
- Photo-electron back-scattering
 - Tails in spatial and timing distributions
- Spatially
 - Worst case: elastic scattering @ 45°
 - Range twice PC/MCPin gap
- Timing
 - Worst case: elastic scattering @ 90°
 - Range twice transit time PC/MCPin



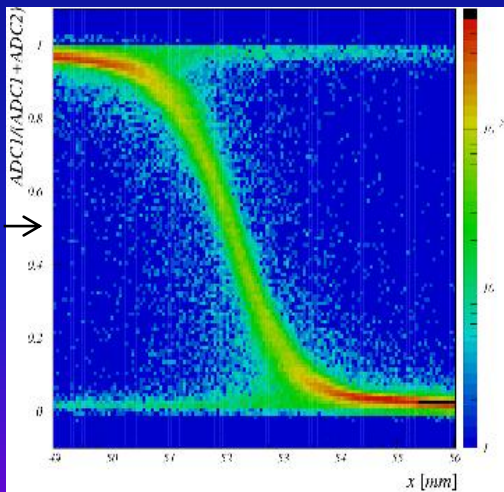
NIMA595 (2008) 169

Typical single photon timing distribution with narrow main peak ($\sigma \sim 40$ ps) and contribution from photoelectron back-scattering.

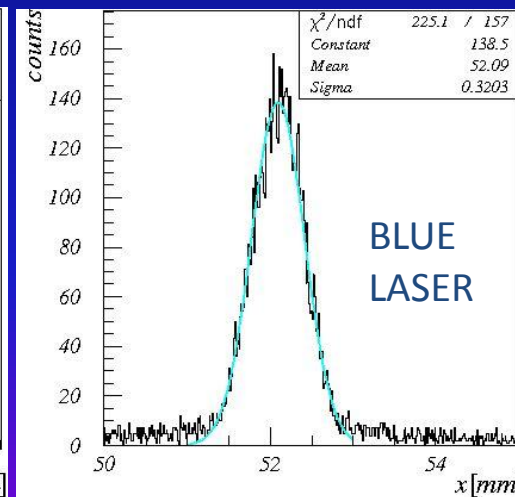
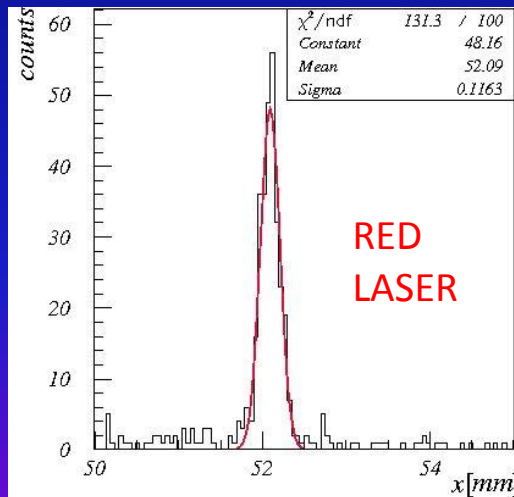
- Secondary electrons spread when traveling from MCPout to anode
- May hit more than one anode pad \rightarrow **Charge sharing**
- May improve spatial resolution but degrade time resolution



NIMA595
(2008) 169

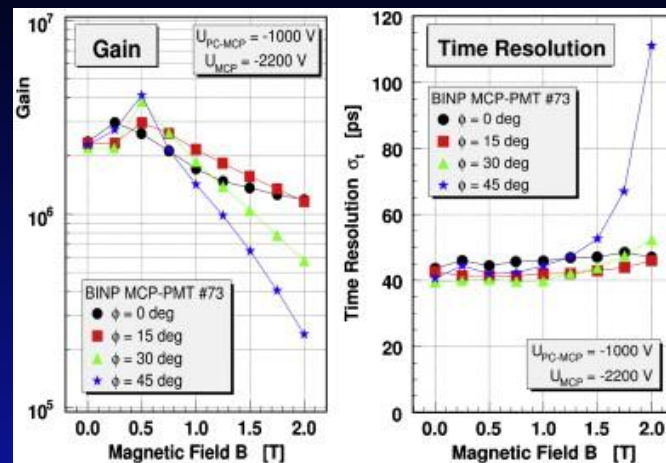


Fraction of the charge detected by left pad as a function of light spot position (red laser)

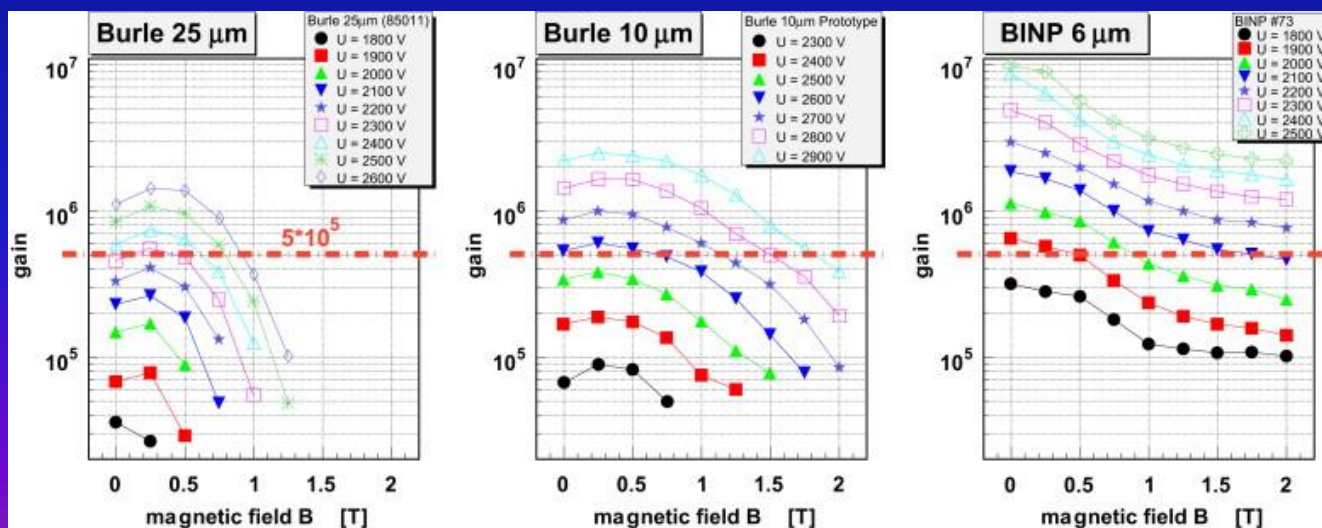


Slices at equal charge sharing for red and blue laser at pad boundary
Resolution limited by photoelectron energy.

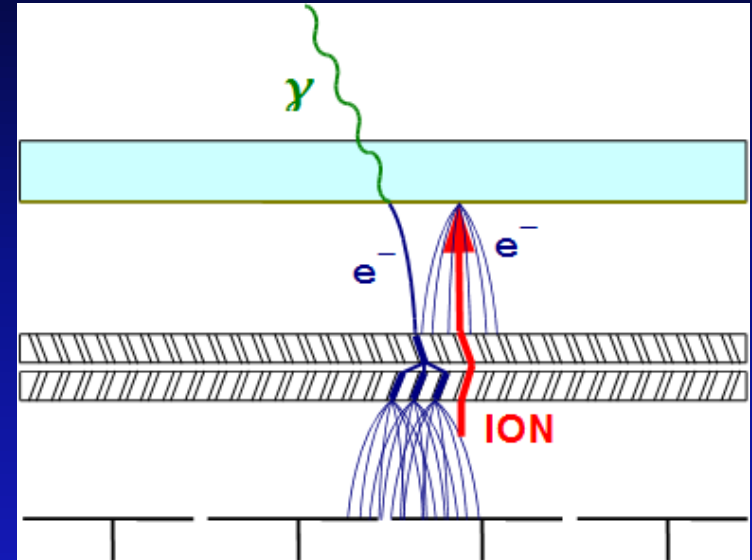
- Narrow amplification channel and proximity focusing electron optics allow operation in magnetic field (\sim axial direction)
- Amplification depends on magnetic field strength and direction
- Effects of charge sharing and photoelectron backscattering on position resolution are strongly reduced while effects on timing remain



NIMA595
(2008) 173



- During the amplification process
 - Atoms of residual gas get ionized and/or desorbed
 - Travel back towards the photocathode and produce secondary pulse
- Ion bombardment damages the photocathode reducing QE
- Atoms may react with and degrade the photocathode
- Overall gain reduction also seen

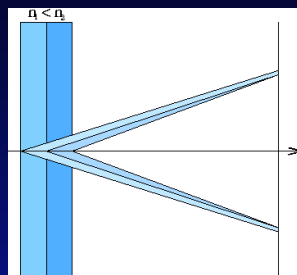


- Improve vacuum quality
- Improve MCP scrubbing
- Make more robust photocathodes
- Investigate new thin-film technologies
- Investigate alternative MCP materials
 - Borosilicate, Alumina, Silicon
- Implement ion barrier film
 - 5-10nm Al_2O_3
 - On MCPin with 40% reduction of collection efficiency
 - Between MCPs
- Seal anode region from PC region

2011 JINST 6 C12026

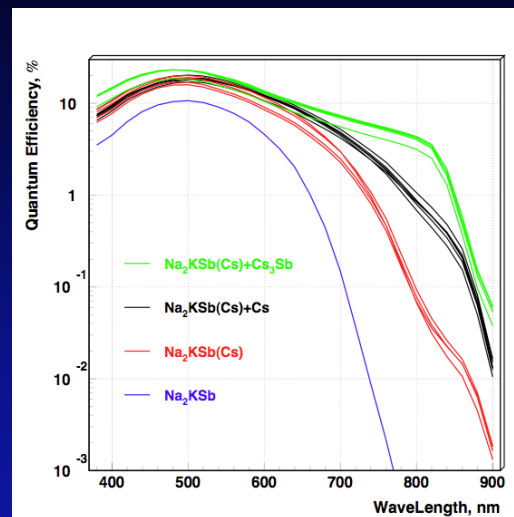
- Developed @ BINP for FARICH concept

- Possible applications
 - Super $c\text{-}\tau$ factory (Novosibirsk)
 - ALICE
 - PANDA forward RICH



- DCR ranges

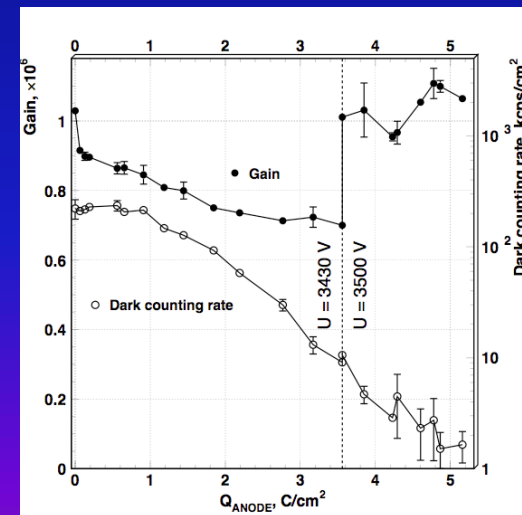
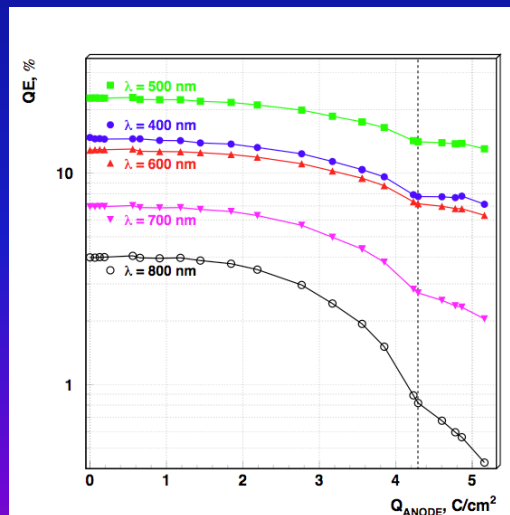
- $\text{Na}_2\text{KSb}(\text{Cs})+\text{Cs}_3\text{Sb}$: 50-100 kHz/cm²
- $\text{Na}_2\text{KSb}(\text{Cs})+\text{Cs}$: 5 kHz/cm²
- $\text{Na}_2\text{KSb}(\text{Cs})$: 0.5 kHz/cm²
- Na_2KSb : <0.5 kHz/cm²



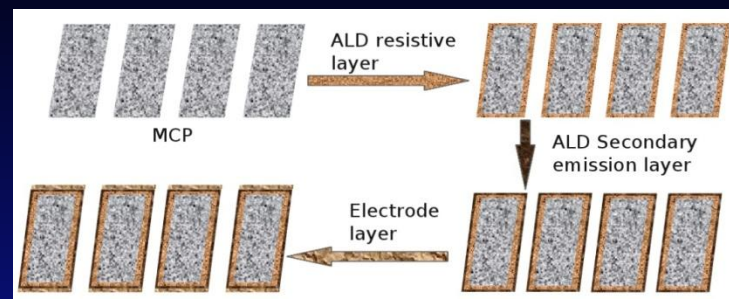
- Test operating parameters

- Counting rate 2-10MHz/cm²
- Gain 10⁶

- Recoverable gain change



See talk of O. Siegmund at this Conference



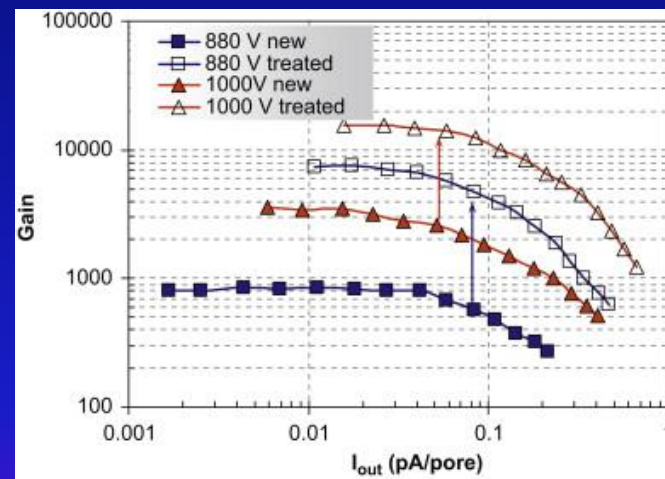
- Three-step deposition process
 - Resistive layer
 - Secondary emission layer
 - Electrode layer

- Optimization of MCP resistance and SEE
 - Independently for each film
 - For a given gain, lower operating voltage

- Allow use of insulating materials other than Pb-glass

- Initiated by the LAPPD Collaboration

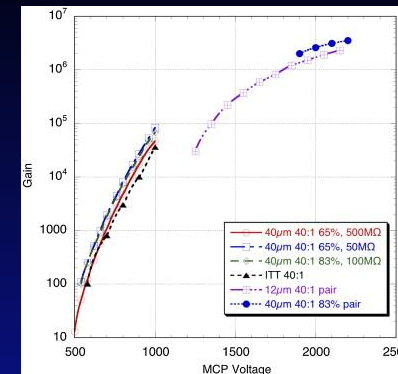
Arradiance



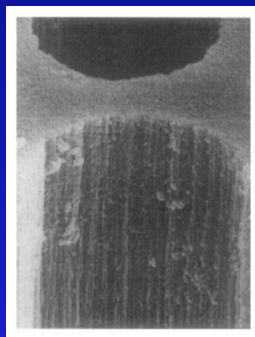
NIMA607
(2009) 81–84

- Borosilicate → See talk of O. Siegmund at this Conference

- In combination with ALD
- "Micro capillary array"
- Large area
- Improved process

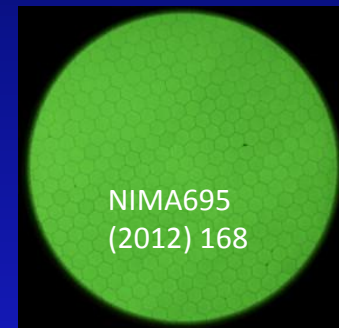


- Anodic alumina →



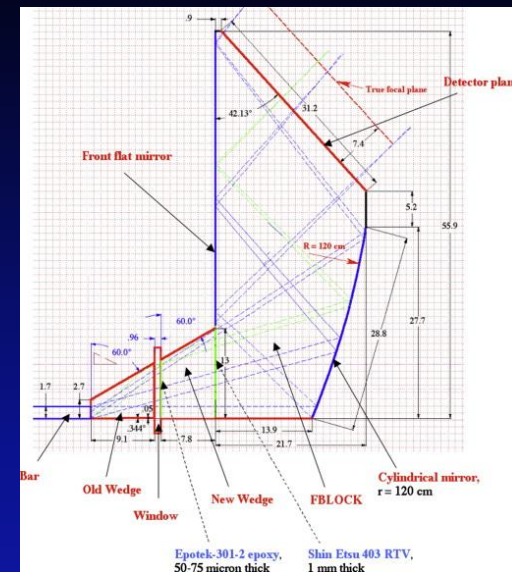
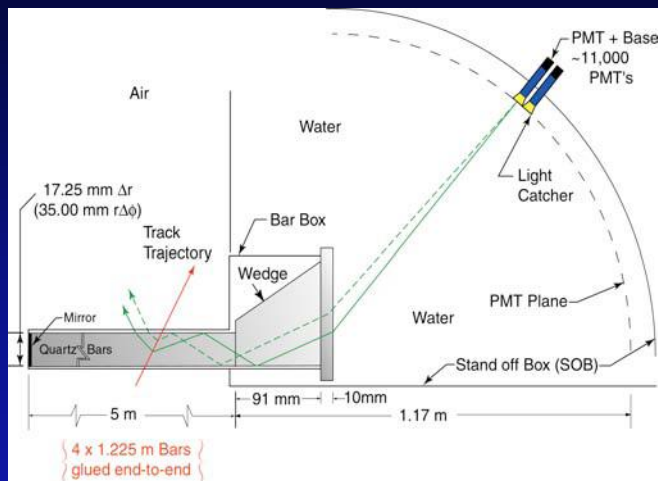
Nucl. Phys. B (Proc. Suppl.) 125
(2003) 394

NIMA567,1 (2006) 290



- Amorphous Si-based → See talk of F. Andrea at this Conference

DIRC concept (BaBar) – 2D imaging

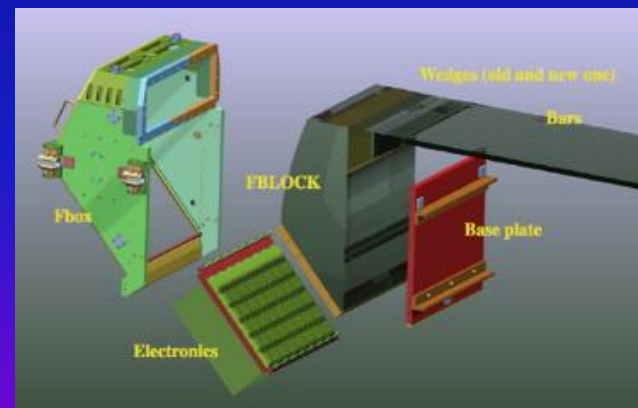


NIMA718 (2013)

Focusing DIRC with chromatic correction (SuperB) uses measured time of propagation to correct chromatic error

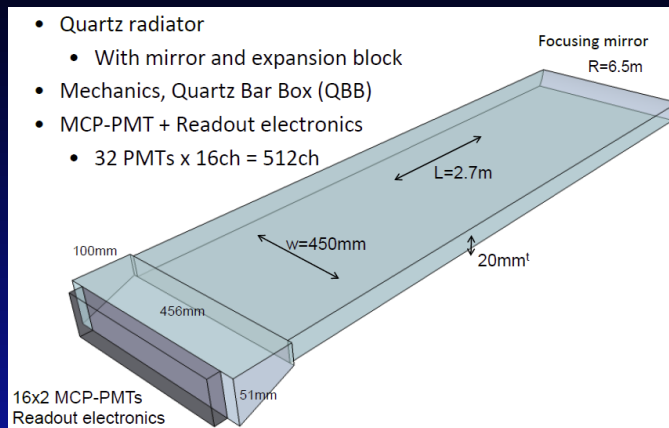
$$t_p = \frac{L_{path}}{v_g} \quad v_g = \frac{c}{n(\lambda) - \lambda \frac{dn}{d\lambda}} \quad (\text{group velocity})$$

Required various MCP-related R&D

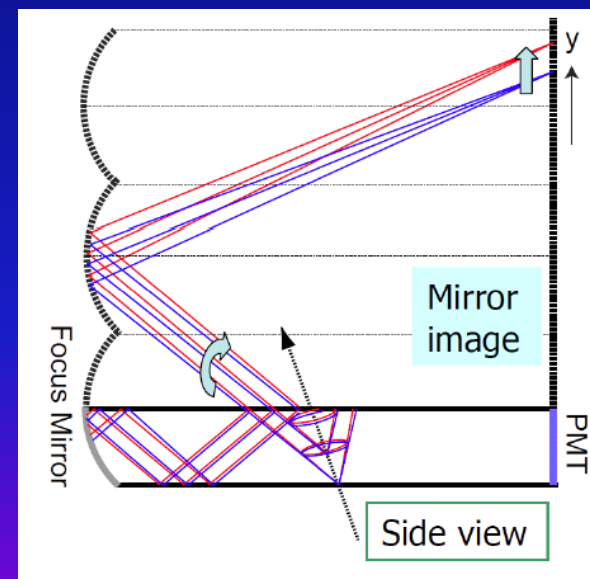
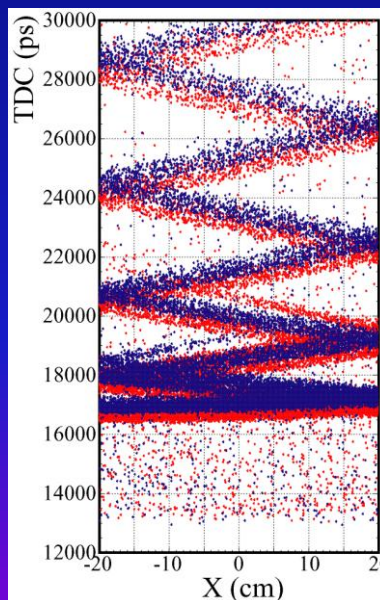


See talk of S. Hirose at this Conference

- Particle ID in Belle II
- TOP (Time-Of-Propagation)
 - Counter based on DIRC concept
 - Using linear array of MCP-PMTs to measure x coordinate and time of propagation (length of photon path)
 - Chromaticity dispersion 100ps
 - Evolved towards iTOP with focussing mirror and y coordinate

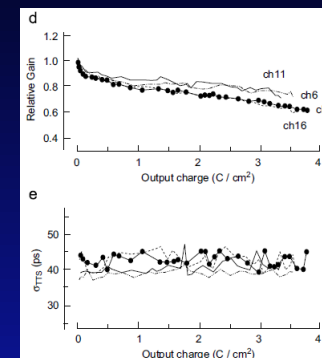
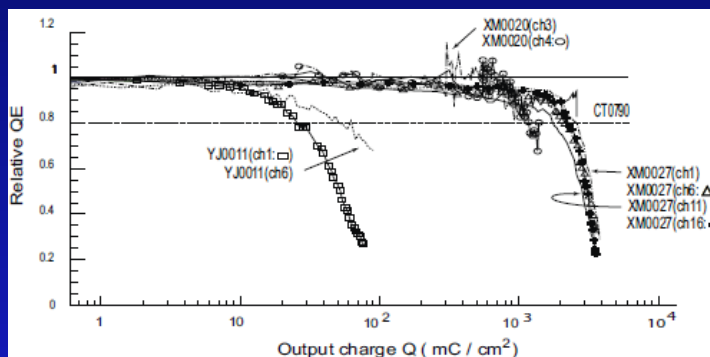
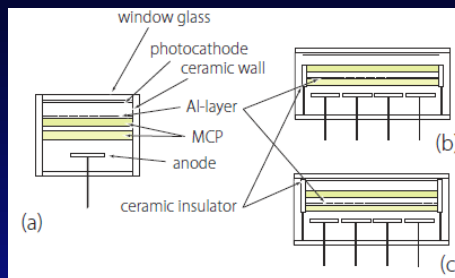


K. Inami RICH2013

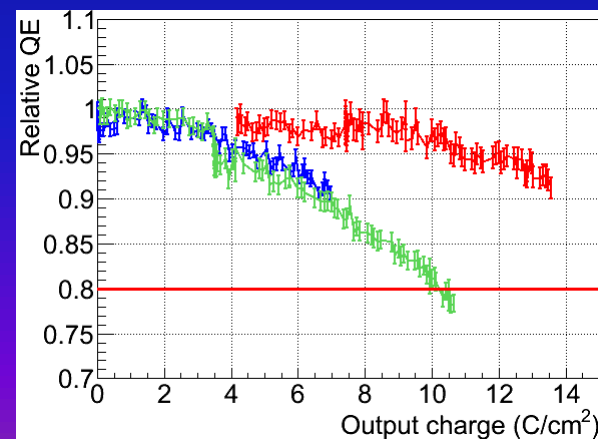


MCP-PMT requirements

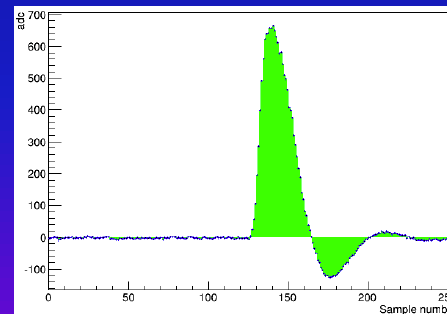
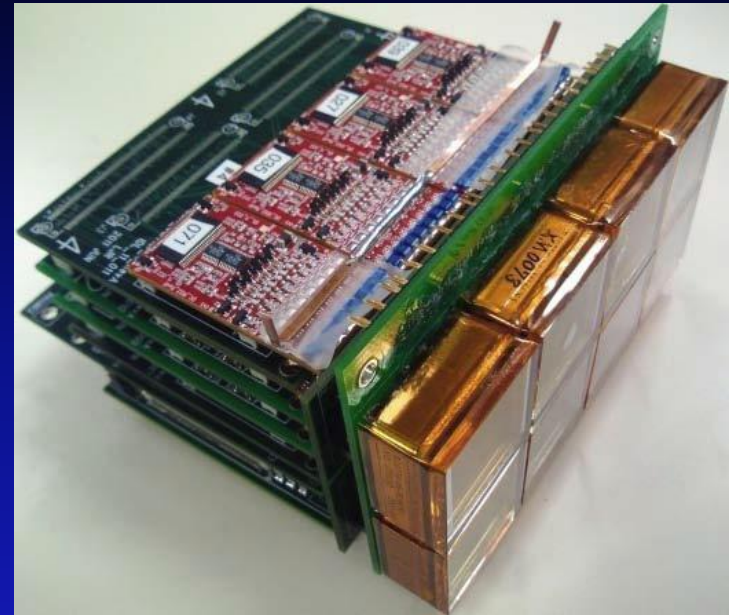
- Integrated charge
 - 1.2-2.4 C/cm²/50 ab⁻¹ (5x10⁵ gain)
 - Lifetime 0.8QE
- Enhanced multi-alkali (>28% QE at peak)
- MCP
 - Channel ϕ 10 μ m
 - bias angle 13°
 - thickness 400 μ m
 - layers 2
- Al protection layer on 2nd MCP + sealing + ALD
- Anode channels 4x4
- Sensitive region 64%
- HV ~ 2500 – 3500 V
- Readout: analogue sampling memory



K. Matsuoka RICH2013



- Time resolution: acceptable up to 100 ps (rms)
- T_0 jitter: acceptable up to 50 ps (rms)
- MCP-PMT signal is read out by newly developed “IRS” (Ice Radio Sampler) series of ASICs
 - Waveform sampling
 - Clear signal read out by ASIC
 - High density, multi-hit buffering 512ch / module, 30kHz trigger rate
 - Clock jitter measured with test pulse is about 20ps.

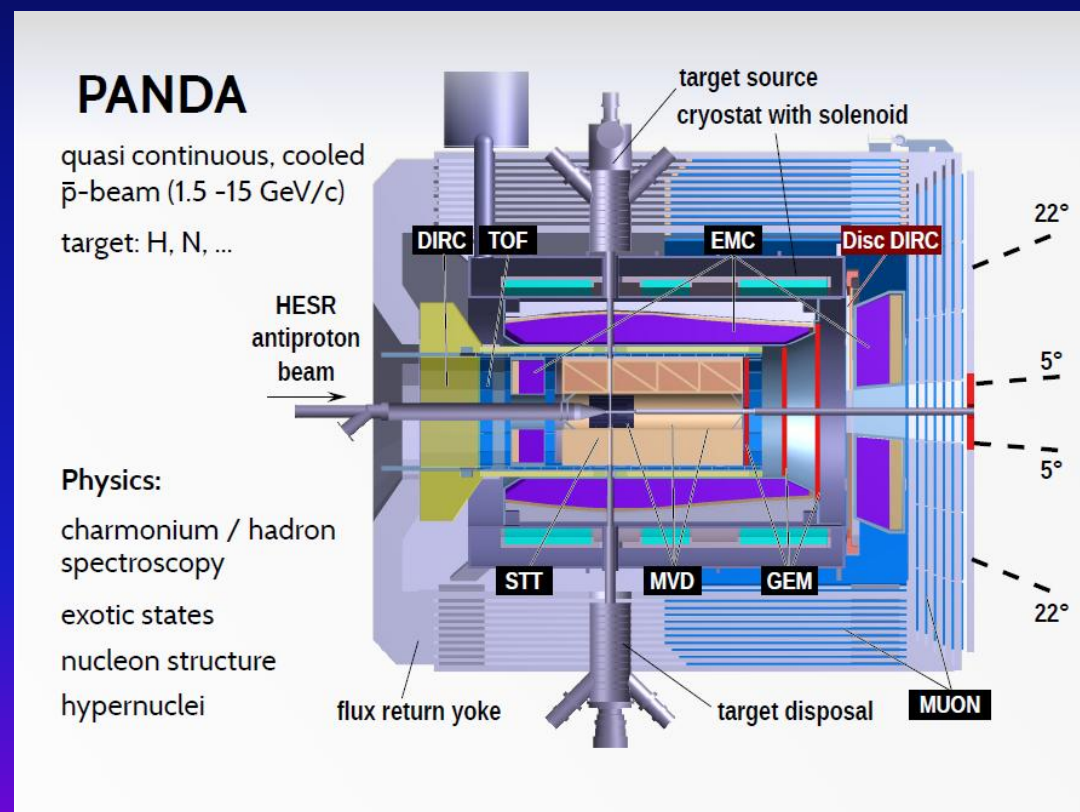


K. Inami
RICH2013

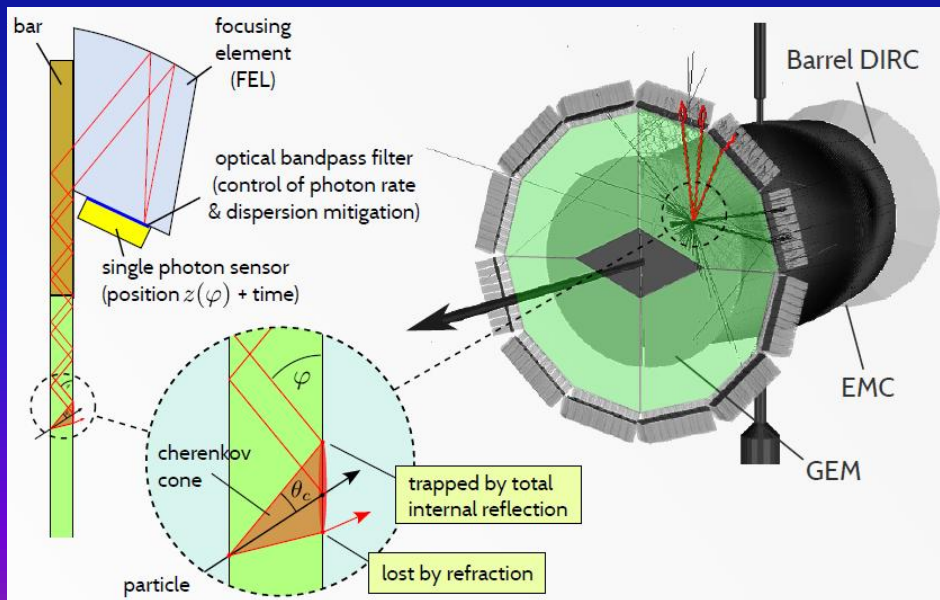
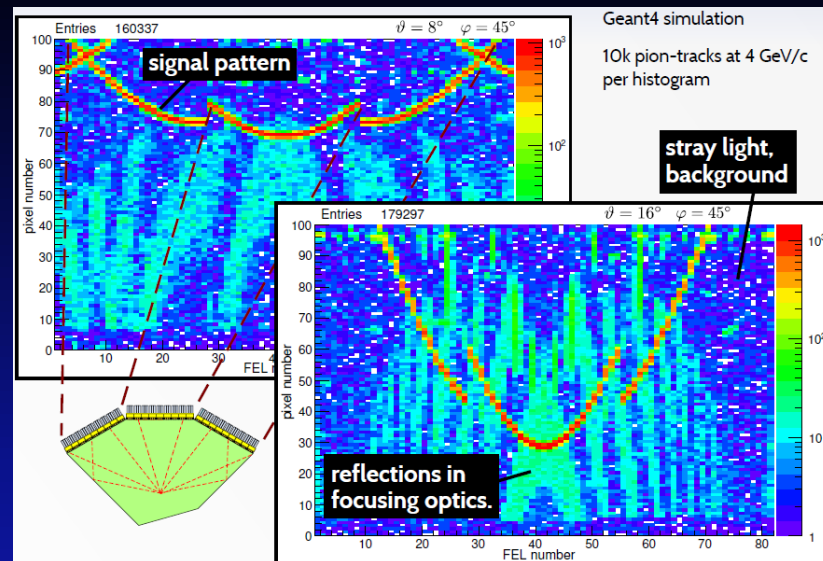
See talk of A. Lehmann at this Conference

O. Merle RICH2013

- Interaction rate
 - cycle average: ~ 10 MHz
 - max. average: ~ 20 MHz
- Require K/π separation up to $4\text{GeV}/c$
- Disc DIRC
 - Very limited space
 - B field 1-2T
 - ~ 3 "Cherenkov emitting" tracks per interaction
 - Triggerless operation
 - 1 MeV n-equivalent fluence $> 2 \cdot 10^{11}$ neq/cm²

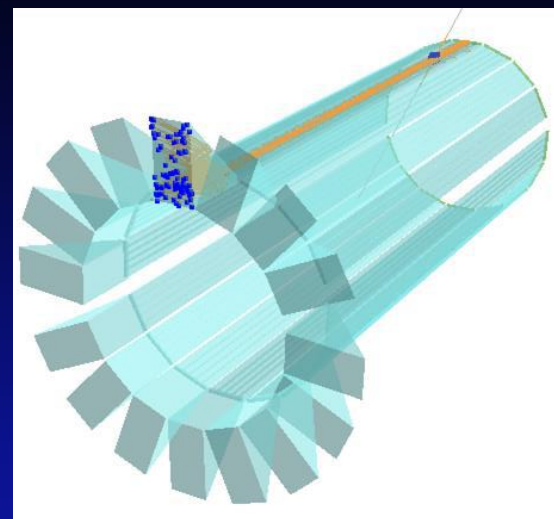


- MCP-PMT requirements
 - Integrated charge $\sim 5.6\text{C}/\text{cm}^2$
 - Rate $\sim 225\text{kHz}/\text{cm}^2$
 - Bfield 1-2T
 - Segmentation 3×100 on 2" sq. tube
- ASIC candidate
 - TOF-PET Rolo et al. 2013 JINST 8 C02050

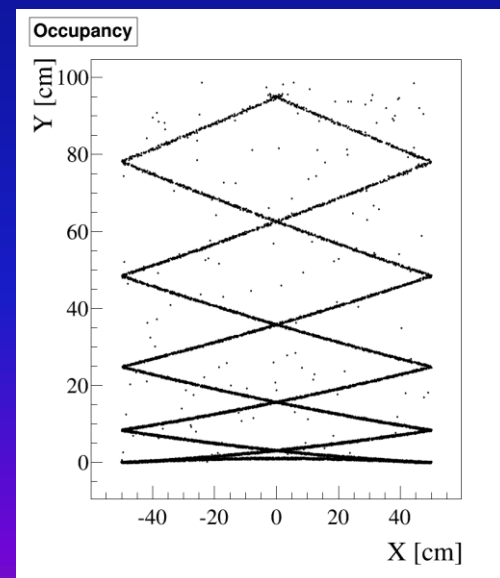
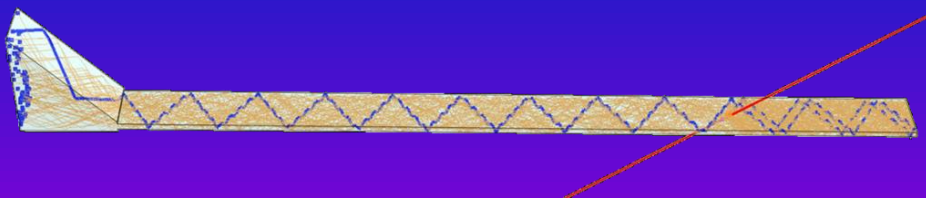


O. Merle RICH2013

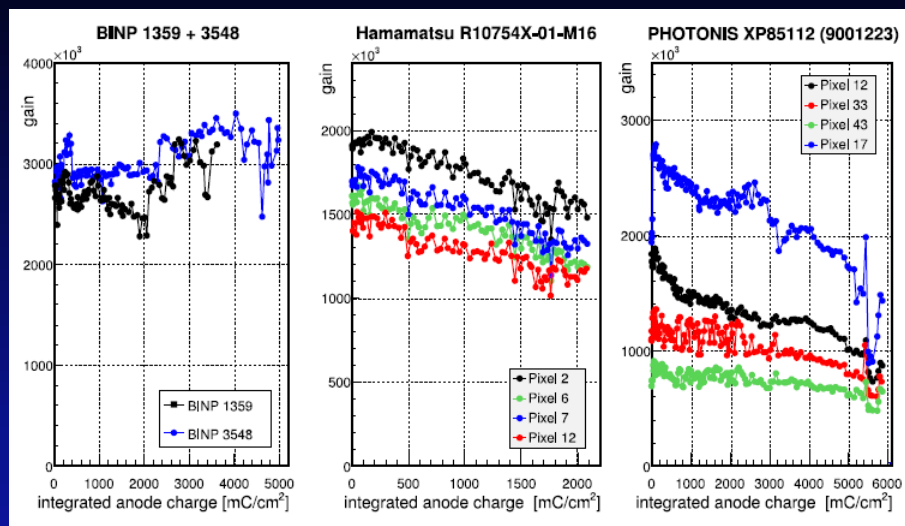
- DIRC concept
- Design similar to BELLE II iTOP
- MCP-PMT requirements
 - Single photon detection
 - Spatial resolution \sim few mm
 - Fast rise time
 - Operation in 1 T field
 - High-rate capability ~ 0.2 MHz/cm²
 - Long lifetime: 0.5 C/cm² per year at 10⁶ gain
 - Photonis 8x8



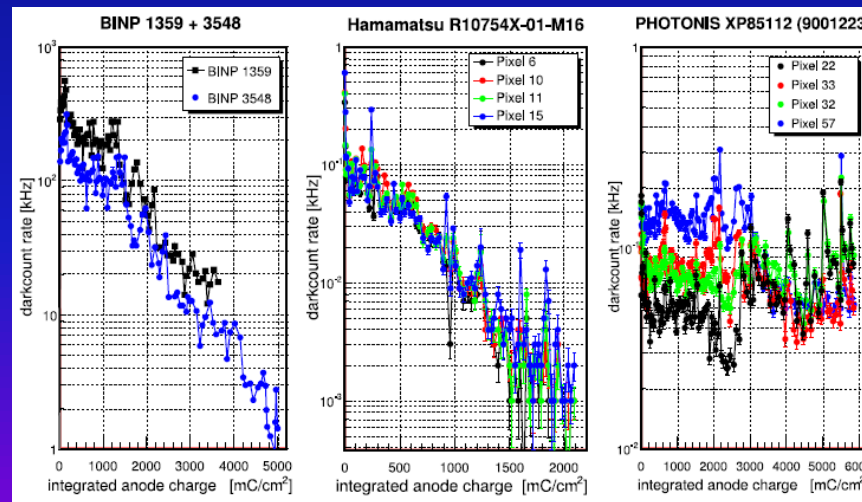
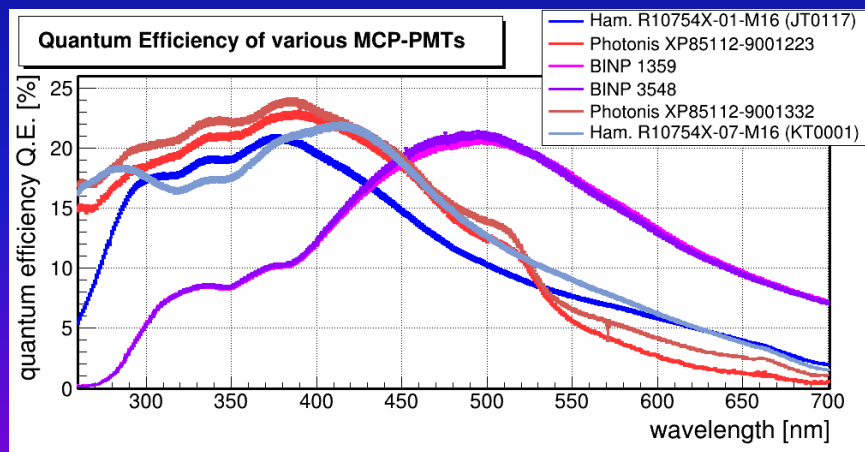
M. Hoek RICH2013



- Moderate MCP gain changes
- Decrease of DCR

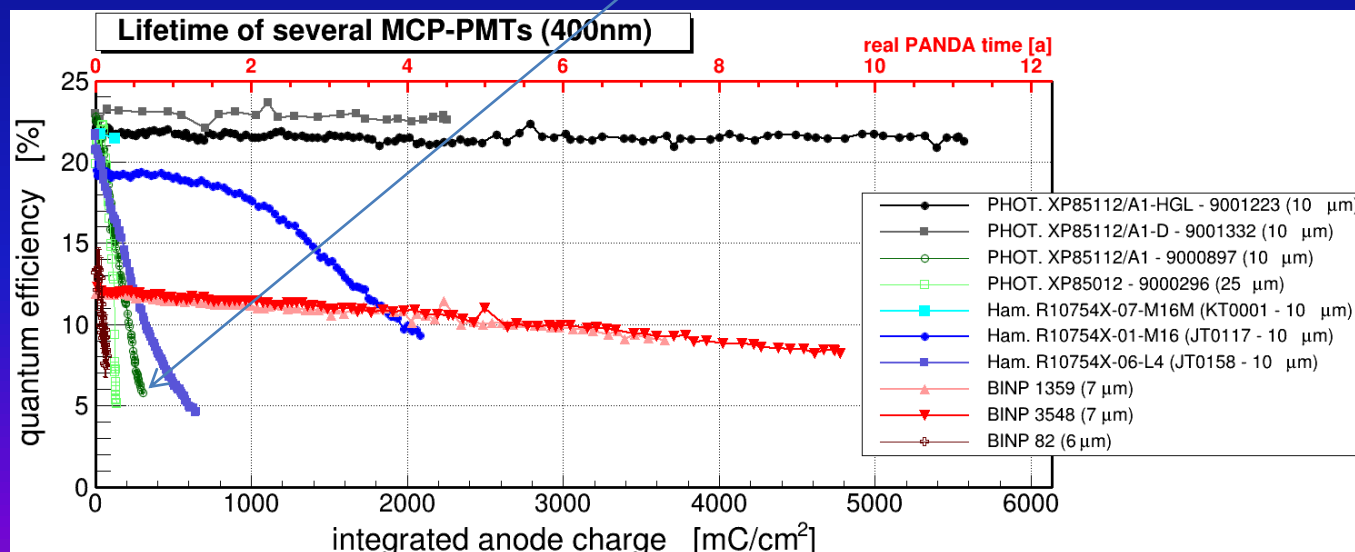
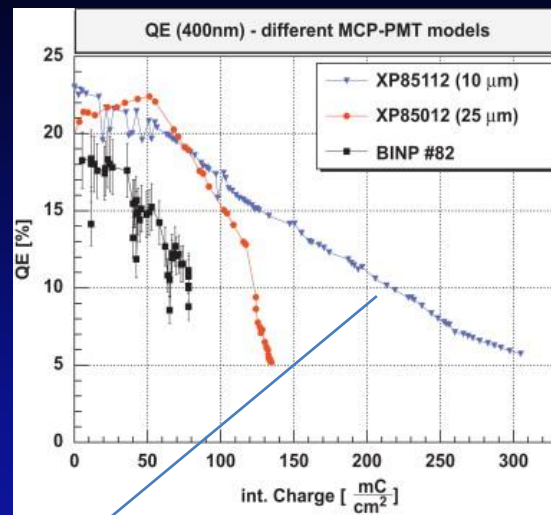


A. Lehmann RICH2013



- Big improvement for ALD-processed MCPs

NIMA 695
(2012) 68

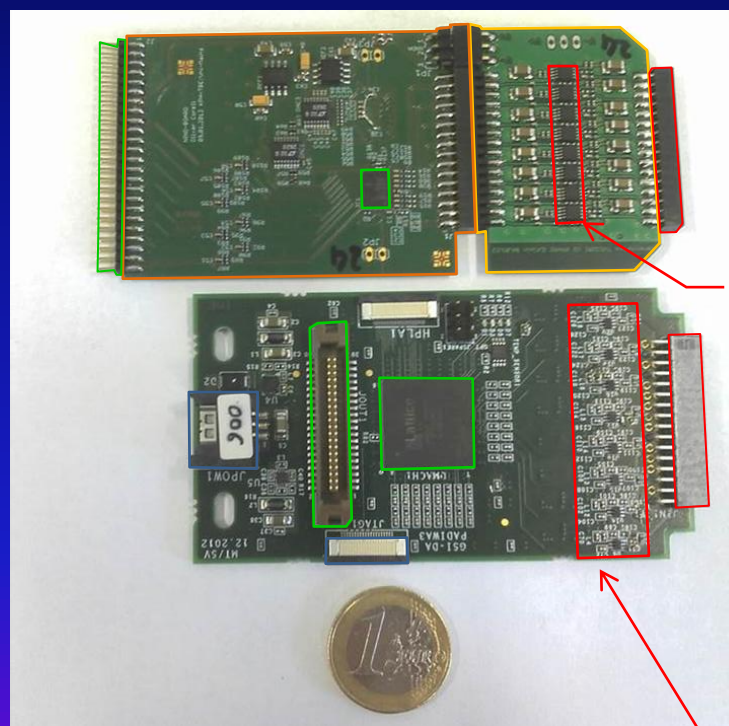
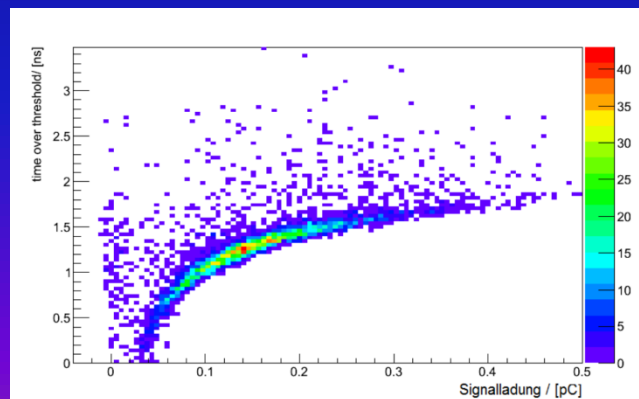


A. Lehmann RICH2013

NIMA 718
(2013) 535

- DAQ system based on TRBv3 board (developed at GSI)
 - High-resolution TDC (<10 ps) based on FPGAs
 - LVDS input signals
 - Precise timing
 - Amplitude information (ToT)
- Compare different technologies
 - ASIC: NINO chip (ALICE TOF)
 - FPGA: PADIWA (GSI)
 - From beam tests TTS O(50ps) achieved

M. Hoek RICH2013



NINO

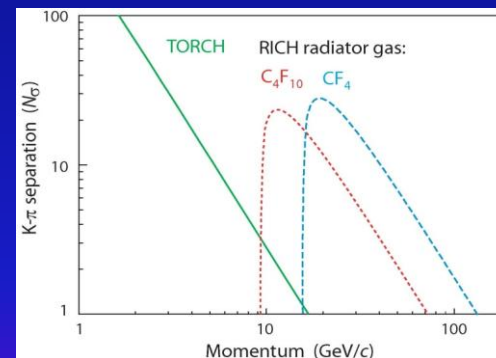
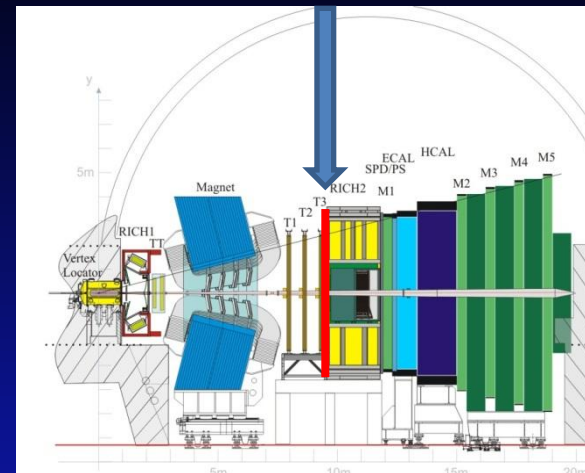
Current feedback amplifier (THS3201)

PADIWA

Pre-amplifier (MMIC)

See talk of L. Castillo García at this Conference

- TORCH (Time Of internally Reflected CHerenkov light) is a possible solution for low-momentum particle ID in LHCb
- Largely inspired by Babar DIRC and iTOP concepts of Belle II
- Want positive identification of kaons in region below their threshold for producing light in the C_4F_{10} gas of RICH-1, i.e. $p < 10 \text{ GeV}/c$
- $\Delta\text{TOF} (\pi\text{-K}) = \sim 35 \text{ ps}$ at $10 \text{ GeV}/c$ over a distance of $\sim 10 \text{ m}$
 \rightarrow aim for $\sim 15 \text{ ps}$ resolution per track
- ERC-funded Project (ERC-2011-AdG, 291175-TORCH)

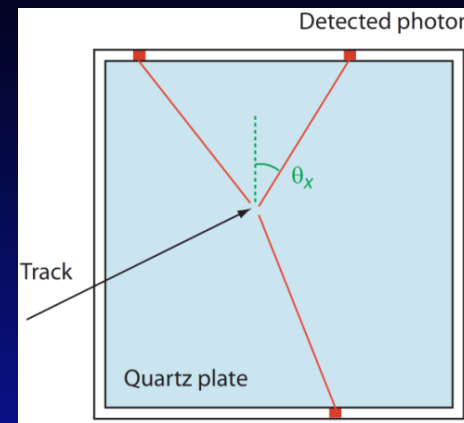
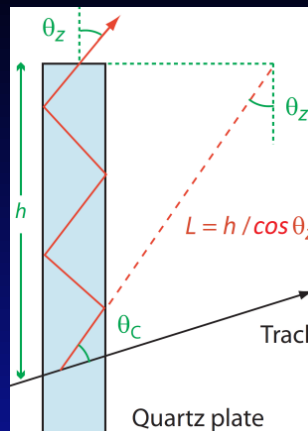


NIMA639
(2011) 173



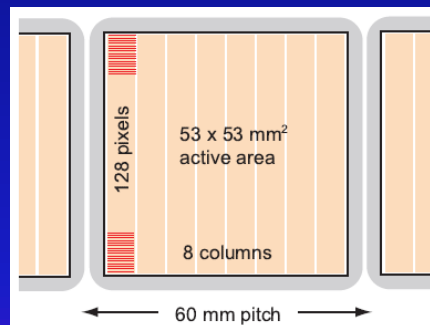
- Reconstruction

- Measure angles θ_x, θ_z of photon trajectory with 1mrad precision to reconstruct photon path length
- Require appropriate focussing optics at periphery and corresponding coarse (θ_x) and fine (θ_z) segmentation of photon detectors

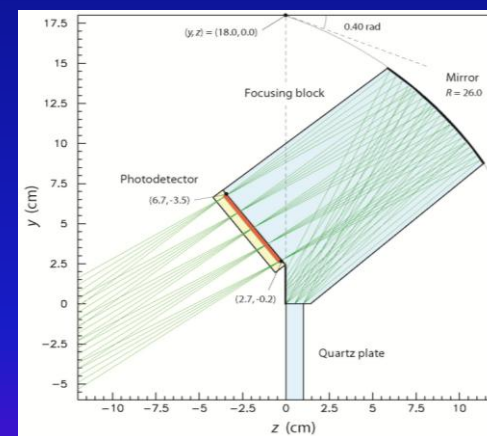


- MCP-PMT requirements

- Segmentation 8x128 (~6.4mmx0.4mm for a 2" tube)
- Typical gain 100fC (6×10^5)
- TTS 50ps for single photons (including electronics)
- 100 tracks per event, 30 detected photons per track every 25ns
=> 1-10MHz/cm² detected photon rate
=> 1-10C/cm² per year



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(2011) 173



- Commercial MCP-PMTs

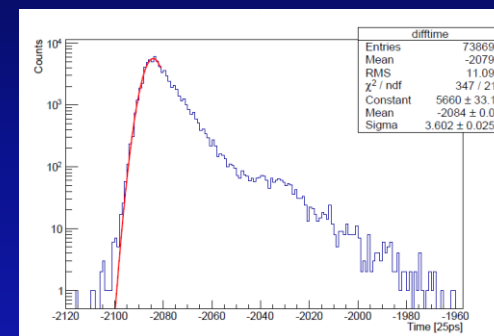
- The closest candidates
 - Planacon 8x8 5.9 mm/6.5 mm in size/pitch
 - Planacon 32x32 1.1 mm/1.6 mm in size/pitch

Photonis



- Measured TTS for single photon
 - 38ps with single-channel electronics
 - ≤ 90 ps with NINO/HPTDC (w/o time walk and non-linearity corrections)

L. Castillo García et al.
ICATPP2013



- Fine segmentation \rightarrow not OK

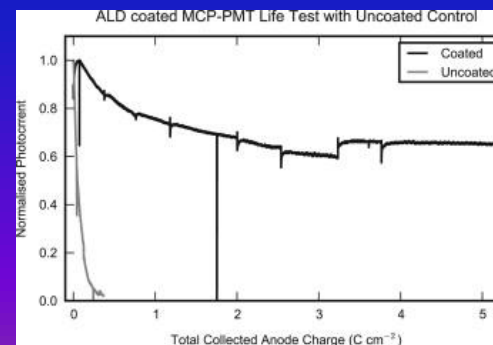
- Custom MCP-PMTs

- Dedicated R&D programme subdivided in three phases
 - Circular devices with extended lifetime
 - Circular devices with required segmentation
 - Square devices with extended lifetime and required



Photek

NIMA732
(2013) 388



- MCP concept is old but technology is still evolving and improving
- Most spectacular progress is on lifetime – to be confirmed long-term on large quantities
- Trend towards finer anode spatial segmentation
- Readout electronics is a challenge
 - High channel count rate
 - High speed
 - High SNR
- Cost aspects!
- Some design guidelines
 - Survey of existing technologies
 - Collaboration with industry: as much as possible, try to combine/match requirements with industrial standards
 - Development of new photon detectors and their associated readout (front-end) electronics should be carried out in parallel but not independently

Note: apologies for any omission!

- @ Session 6 – High Energy Physics
 - L. Burmistrov, “Cherenkov detector for proton Flux Measurement (CpFM)”
- @ Session 10 – Cherenkov Detectors
 - S. Hirose, “Development of the MCP-PMT for the Belle II TOP Counter”
 - L. Castillo García, “MCP photon detectors studies for the TORCH detector”
- @ Session 11 – Innovative Photodetectors
 - L. Hiirvonen, “Sub-exposure-time time resolution in wide-field time-correlated single photon counting imaging”

- @ Session 12 – MCPs
 - Q. Sen “The Status of MCP-PMT R&D in China”
 - O. Siegmund, “Application of Atomic Layer Deposited Microchannel Plates to Imaging Photodetectors with High Time Resolution”
 - F. Andrea et al., “Latest results about the performances of amorphous silicon-based microchannel plate”
 - A. Lehmann et al., “Breakthrough in the Lifetime of Microchannel-Plate PMTs”
 - V. Yurevich, “Development and study of picosecond start and trigger detector for high-energy heavy ion experiments”
- @ Session 16 – Readout Electronics
 - J. Lapington et al., “The capacitive division image readout; an imaging technique combining high time and spatial resolution”
 - M. Fiorini et al., “CLARO-CMOS: a fast, low power and radiation-hard front-end ASIC for single-photon counting in 0.35 micron CMOS technology”

- @ Poster Session #2
 - M. Minot et al., “Pilot Production & Commercialization of LAPPD™”
 - L. Giudicotti, “Gain saturation in microchannel plate detectors”
 - A. Tremsin, “Optimization of High Count Rate Photon Counting Detector with Microchannel Plates and Quad Timepix readout”
- @ Poster Session #3
 - S. Leach et al., “Optimising image resolution for photon-counting detectors using adaptive pulse processing”

Solid materials (usually semiconductors)

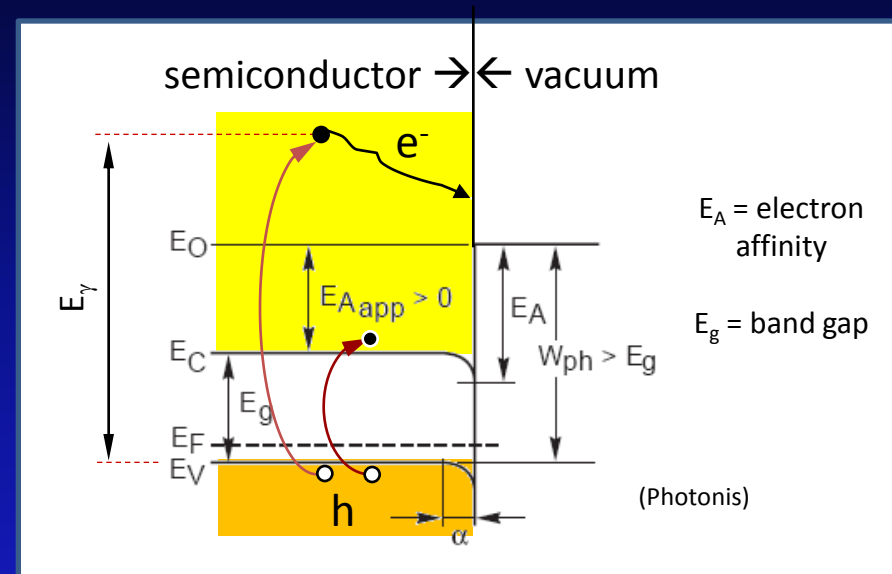
Multi-step process:

- absorbed γ 's impart energy to electrons (e) in the material; If $E_\gamma > E_g$, electrons are lifted to conduction band.
 → In a Si-photodiode, these electrons can create a photocurrent. → Photon detected by **Internal Photoeffect**.

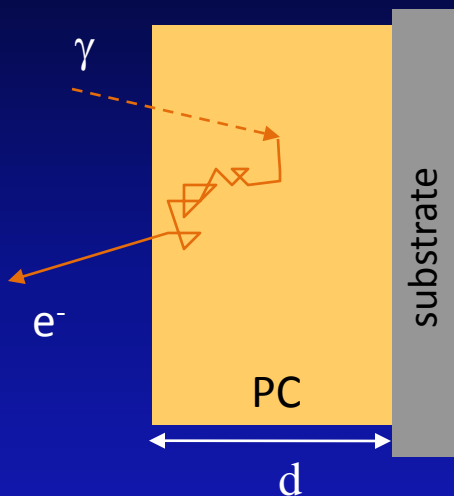
However, if the detection method requires extraction of the electron, 2 more steps must be accomplished:

- energized e's diffuse through the material, losing part of their energy (\sim random walk) due to electron-phonon scattering. $\Delta E \sim 0.05$ eV per collision. Free path between 2 collisions $\lambda_f \sim 2.5 - 5$ nm → escape depth $\lambda_e \sim$ some tens of nm.
- only e's reaching the surface with sufficient excess energy escape from it
 → **External Photoeffect**

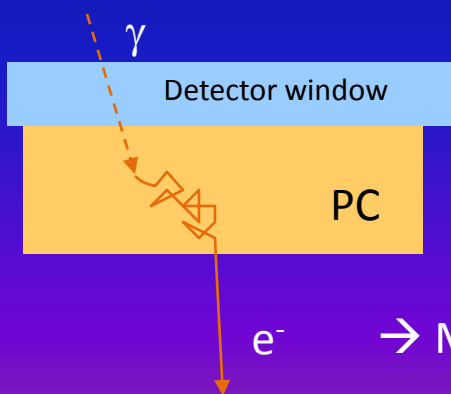
$$E_\gamma = h\nu > W_{ph} = E_G + E_A$$



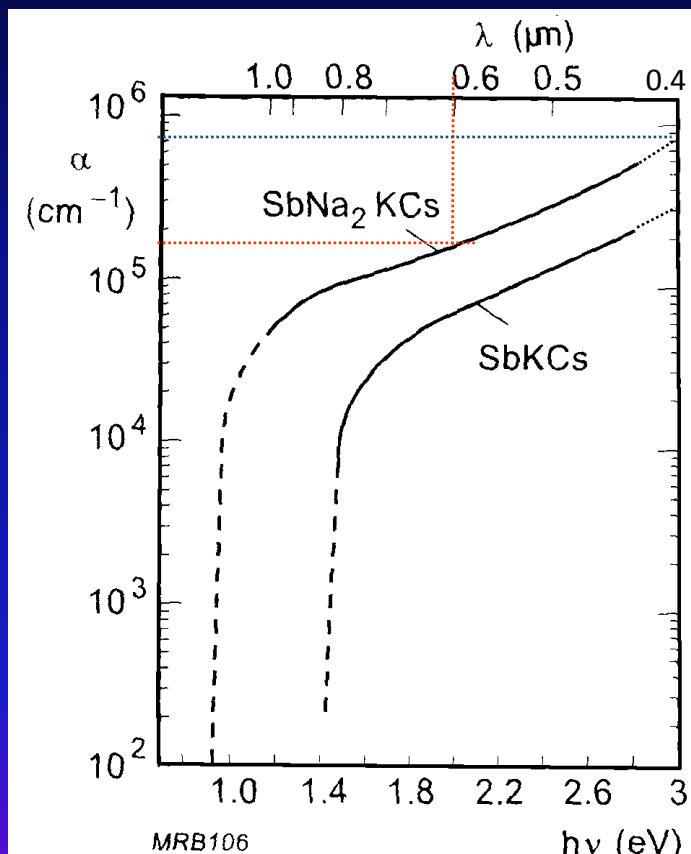
Opaque photocathode



Semitransparent photocathode



Light absorption in photocathode



$$N = N_0 \cdot \exp(-\alpha d)$$

$$\lambda_A = 1/\alpha$$

Red light ($\lambda \approx 600 \text{ nm}$)

$$\alpha \approx 1.5 \cdot 10^5 \text{ cm}^{-1}$$

$$\lambda_A \approx 60 \text{ nm}$$

Blue light ($\lambda \approx 400 \text{ nm}$)

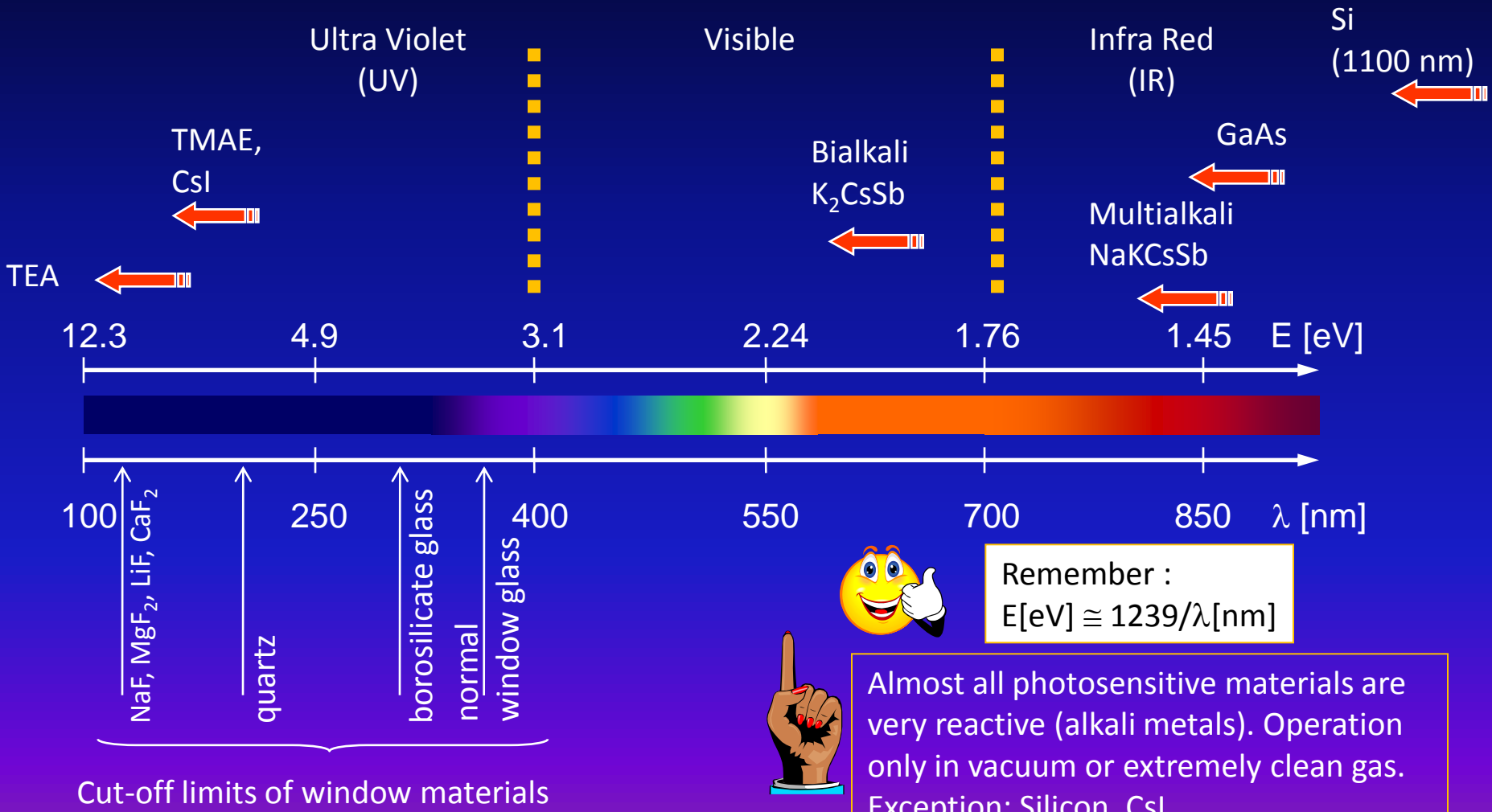
$$\alpha \approx 7 \cdot 10^5 \text{ cm}^{-1}$$

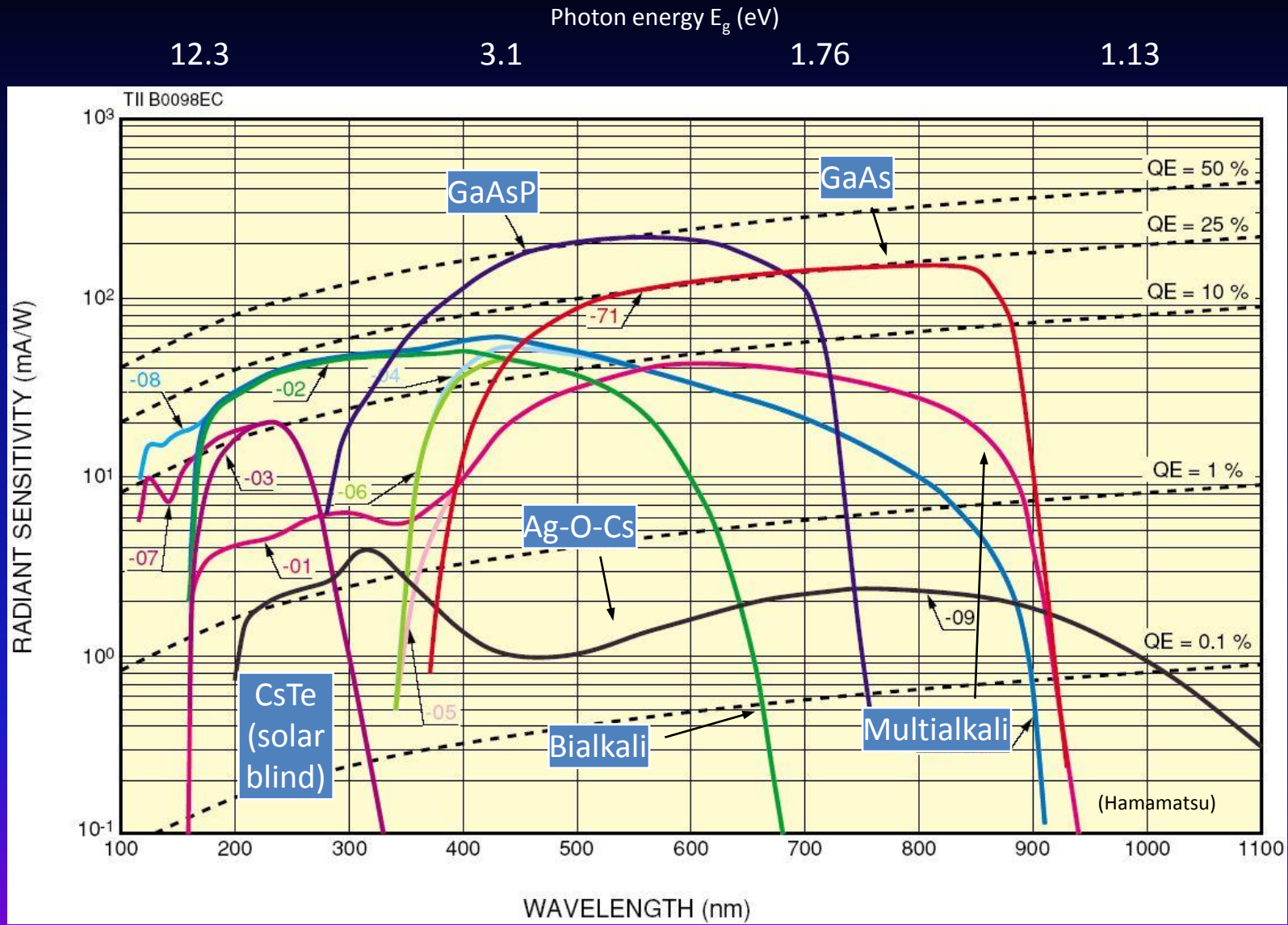
$$\lambda_A \approx 15 \text{ nm}$$

Blue light is stronger absorbed than red light !

→ Make semitransparent photocathode just as thick as necessary!

← begin of arrow indicates threshold





Bialkali: SbKCs, SbRbCs Multialkali: SbNa₂KCs (alkali metals have low work function)

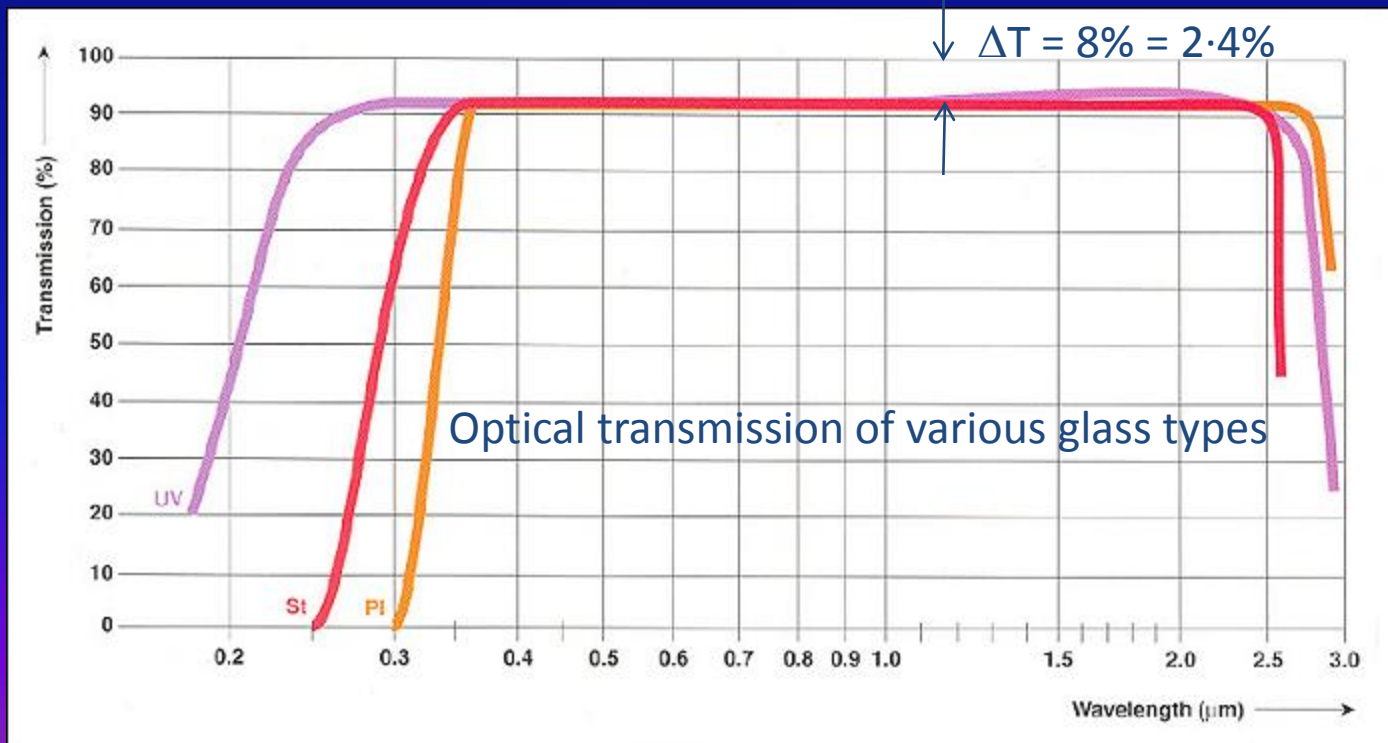
2 types of losses:

- Fresnel reflection at interface air/window and window/photocathode

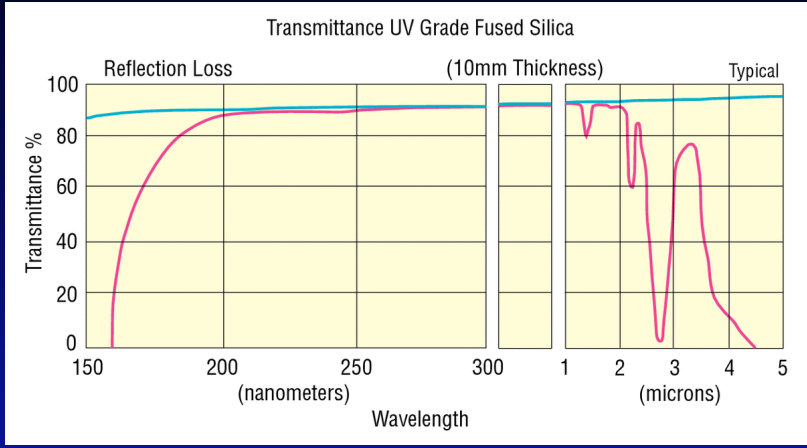
$$R_{\text{Fresnel}} = (n-1)^2 / (n+1)^2 \quad n = \text{refractive index (wavelength dependent!)}$$

$$n_{\text{glass}} \sim 1.5 \quad R_{\text{Fresnel}} = 0.04 \text{ (per interface)}$$

- Bulk absorption due to impurities or intrinsic cut-off limit. Absorption is proportional to window thickness



Schott



Newport

